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Bib Data Sheet

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|-----------------------------|---------------------------------------|--------------|------------------------|--|
| SERIAL NUMBER 10/765,390 | FILING DATE 01/28/2004 RULE | CLASS 356 | GROUP ART UNIT 2877 | ATTORNEY DOCKET NO. 00862.023423 |
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APPLICANTS

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** CONTINUING DATA *****

none

** FOREIGN APPLICATIONS *****

JAPAN 2003-024964 01/31/2003

yes

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/14/2004

| | | | | |
|--|--------------------|---------|--------|-------------|
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | STATE OR | SHEETS | TOTAL | INDEPENDENT |
| 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | COUNTRY | DRAWING | CLAIMS | CLAIMS |
| Verified and Acknowledged | JAPAN | 10 | 15 | 2 |
| Examiner's Signature <i>James C. Williams</i> | Initials <i>JM</i> | | | |

ADDRESS

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TITLE

Substrate alignment apparatus and method, and exposure apparatus

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|-----------------------------------|---|---|
| FILING FEE RECEIVED 770 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ |
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